



Docket No.: 0020-5179P  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Zhiqiang WEI et al.

Application No.: 10/665,496

Confirmation No.: 6865

Filed: September 22, 2003

Art Unit: 1762

For: A THIN FILM METAL OXIDE AND A  
METHOD FOR PREPARING IT

Examiner: M. B. Cleveland

**AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION**

MS RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated January 9, 2006, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 8 of this paper.

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